



HIGH-CAPACITY NANOSTRUCTURED SILICON...
Jason Graetz et al.
Appl. No.: 10/660,382 Atty. Docket: CTJPL.008A

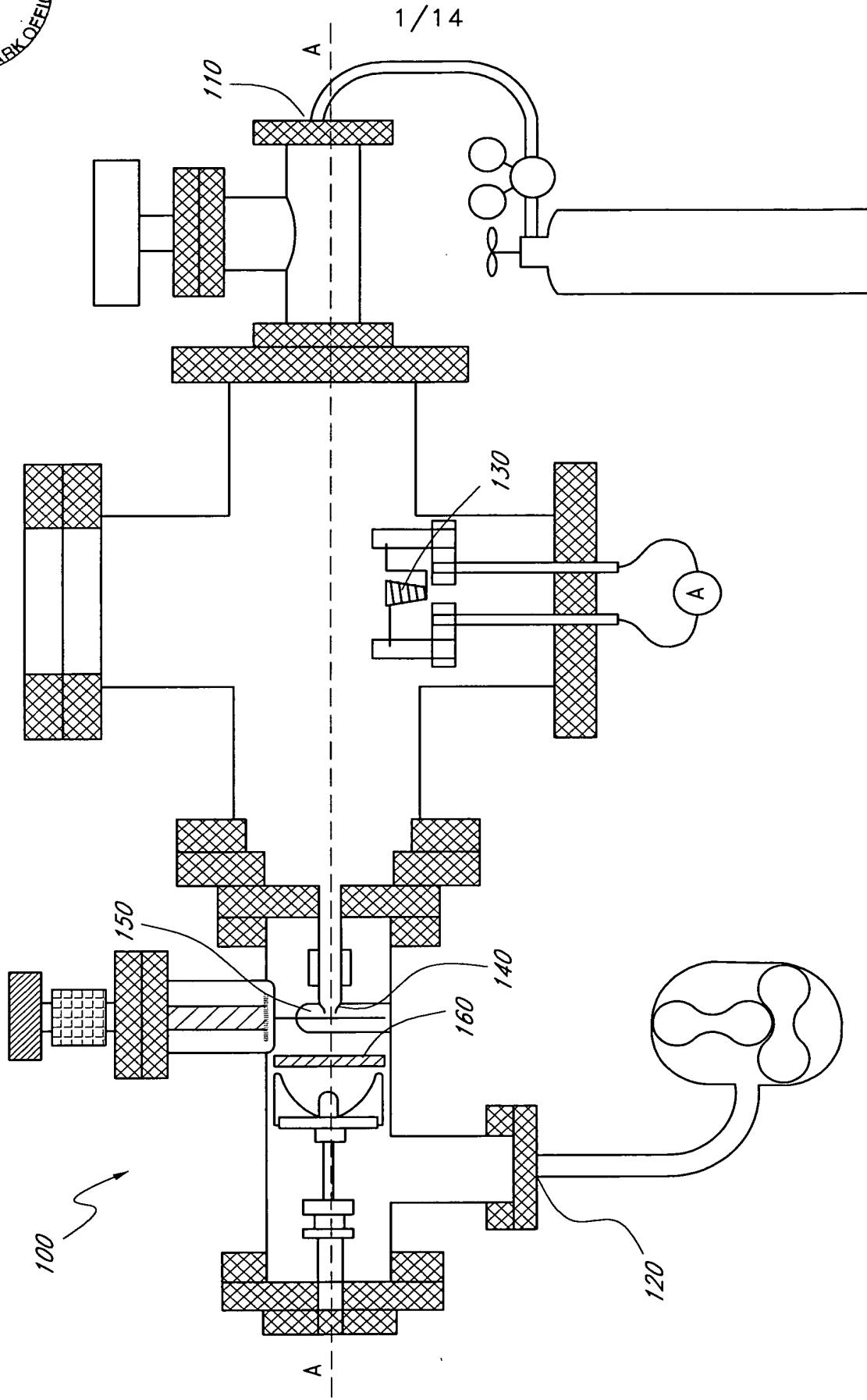


FIG. 1

2/14

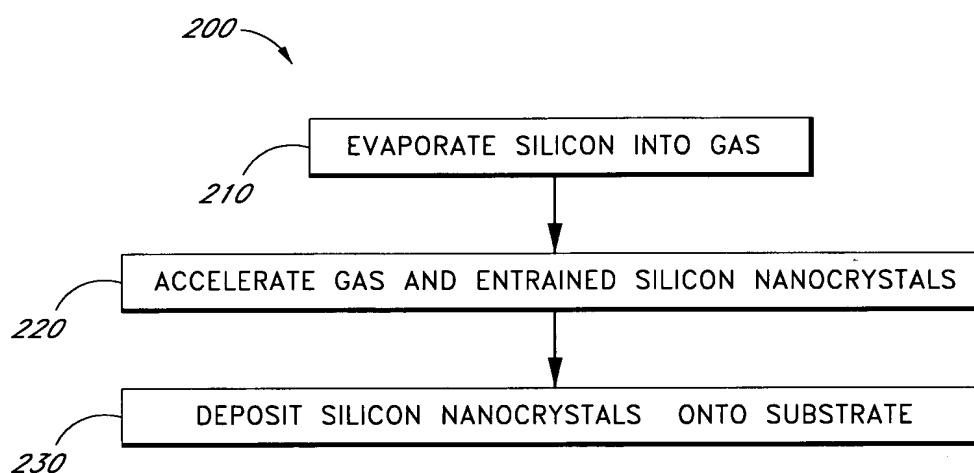


FIG.2

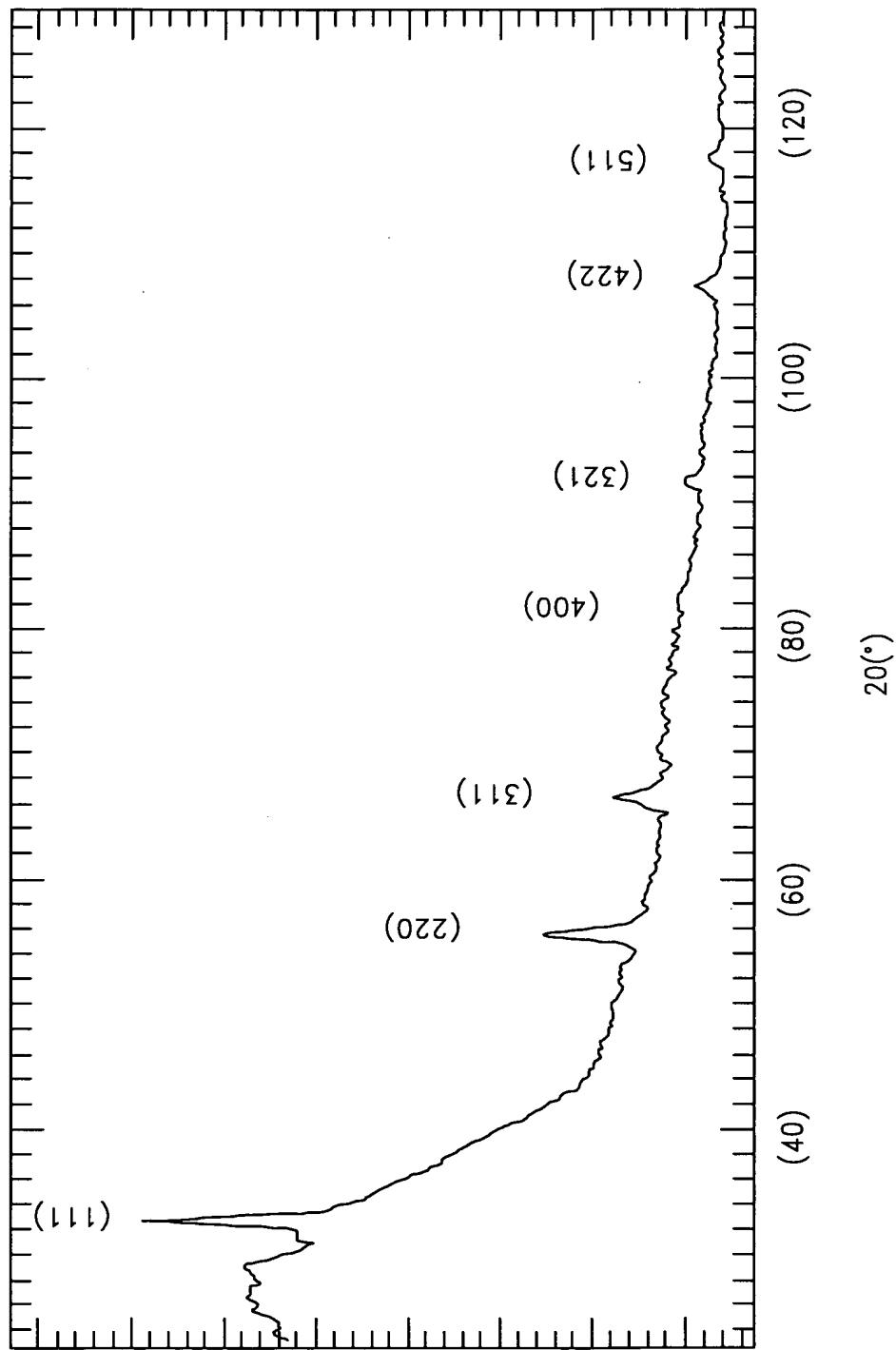


FIG. 3

HIGH-CAPACITY NANOSTRUCTURED SILICON...
Jason Graetz et al.
Appl. No.: 10/660,382 Atty. Docket: CTJPL.008A

4/14

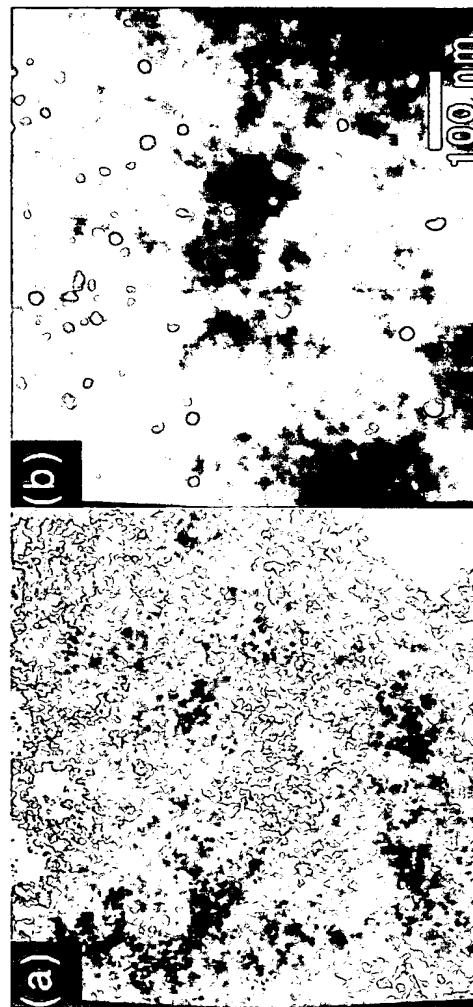


FIG. 4A
FIG. 4B

HIGH-CAPACITY NANOSTRUCTURED SILICON...

Jason Graetz et al.

Appl. No.: 10/660,382 Atty. Docket: CTJPL.008A

5/14

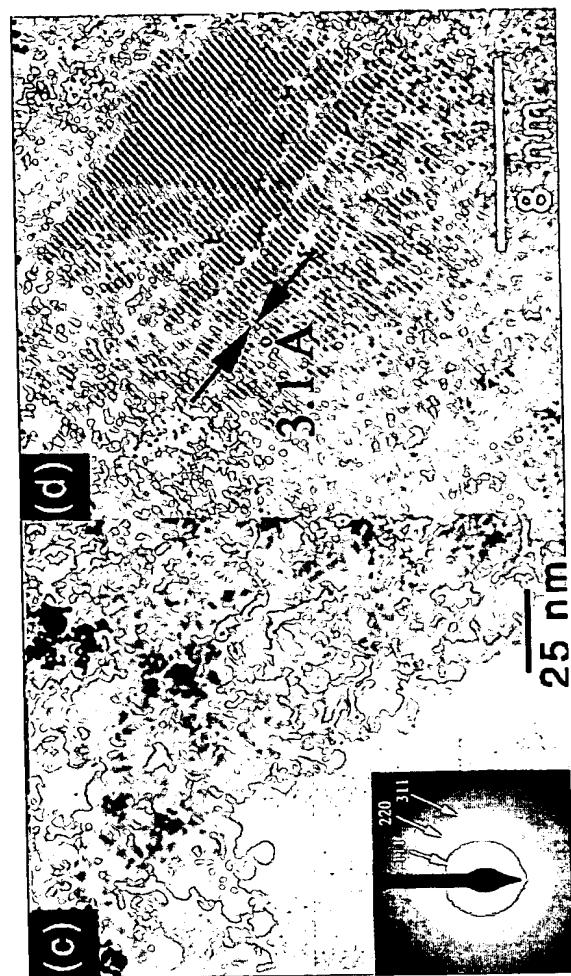


FIG. 4C
FIG. 4D

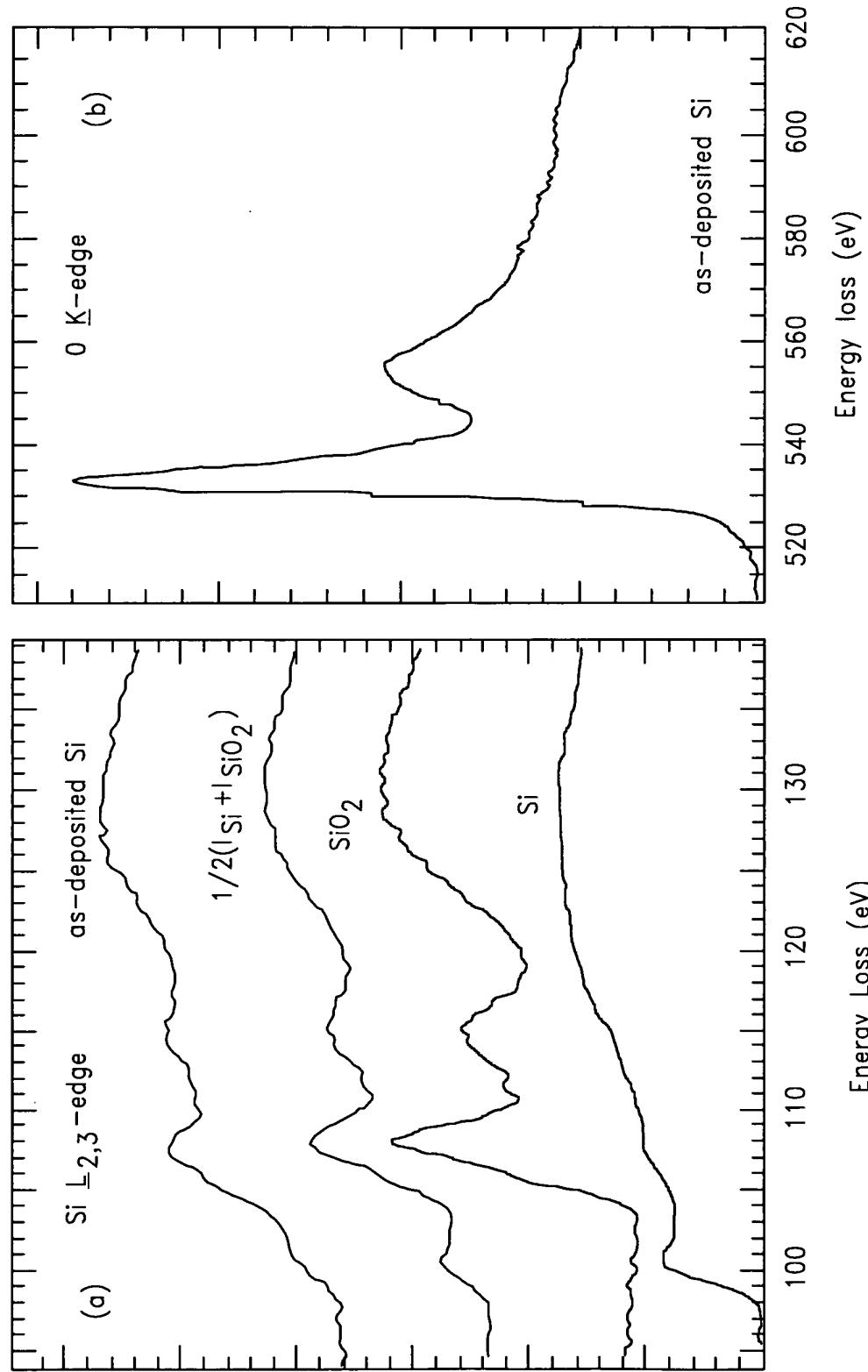


FIG. 5B

FIG. 5A

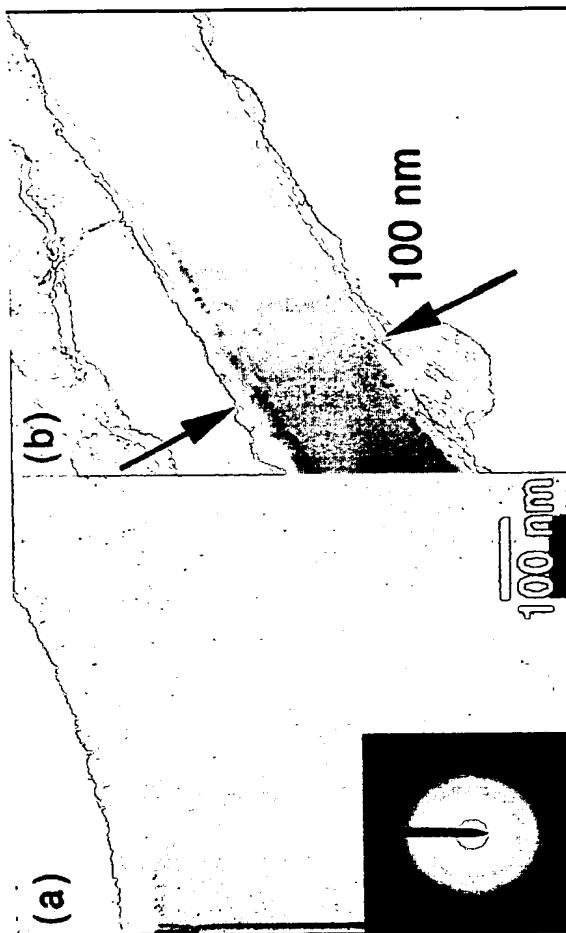


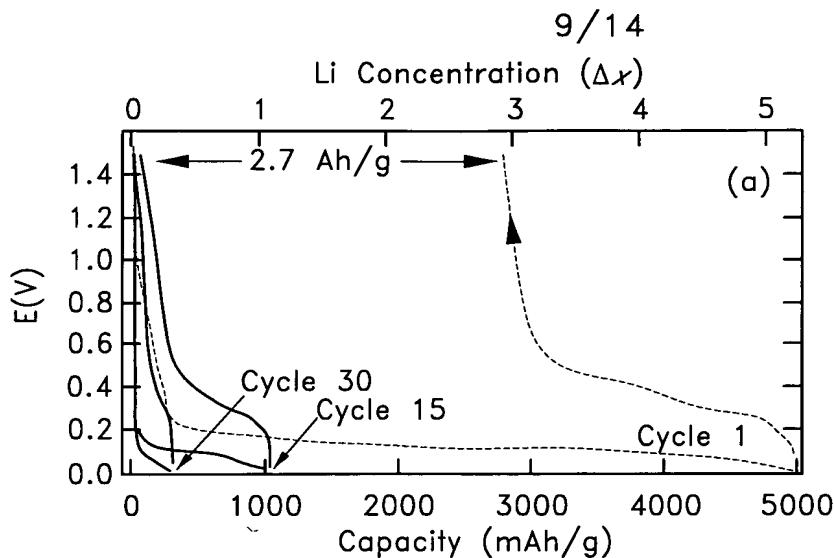
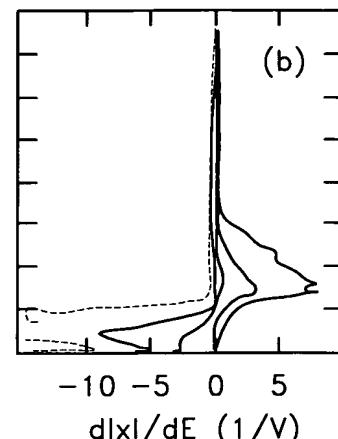
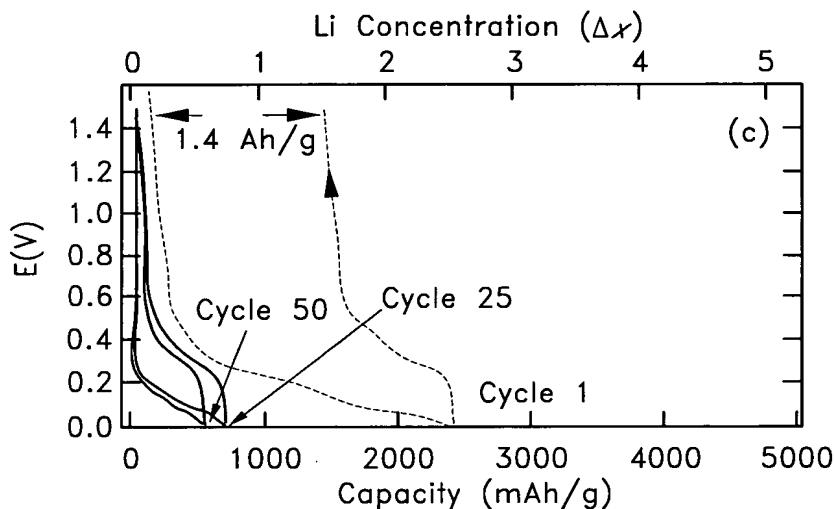
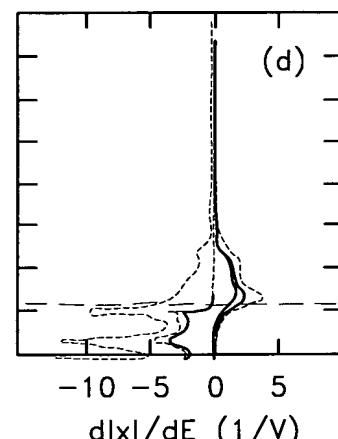
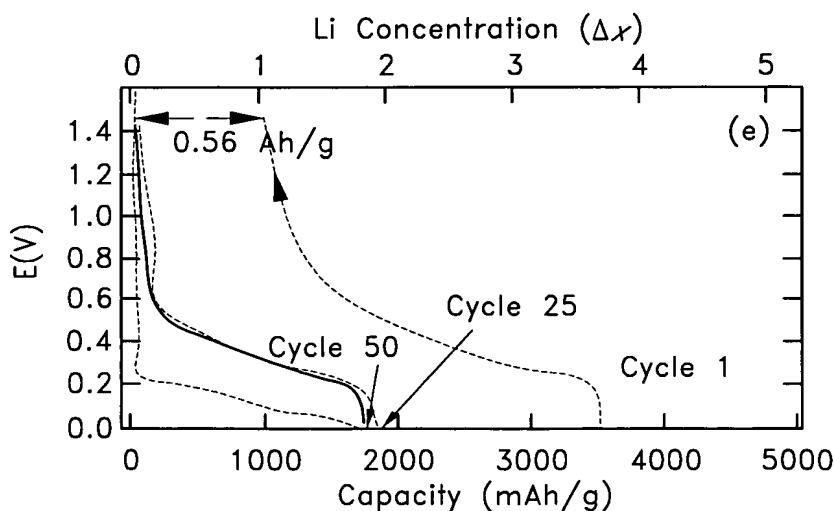
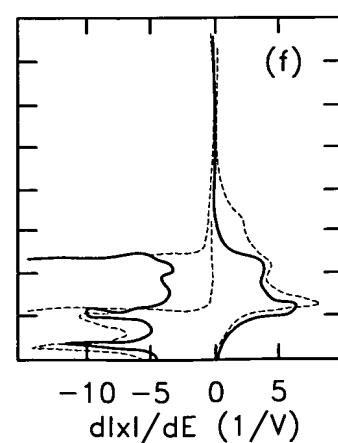
FIG. 6B
FIG. 6A

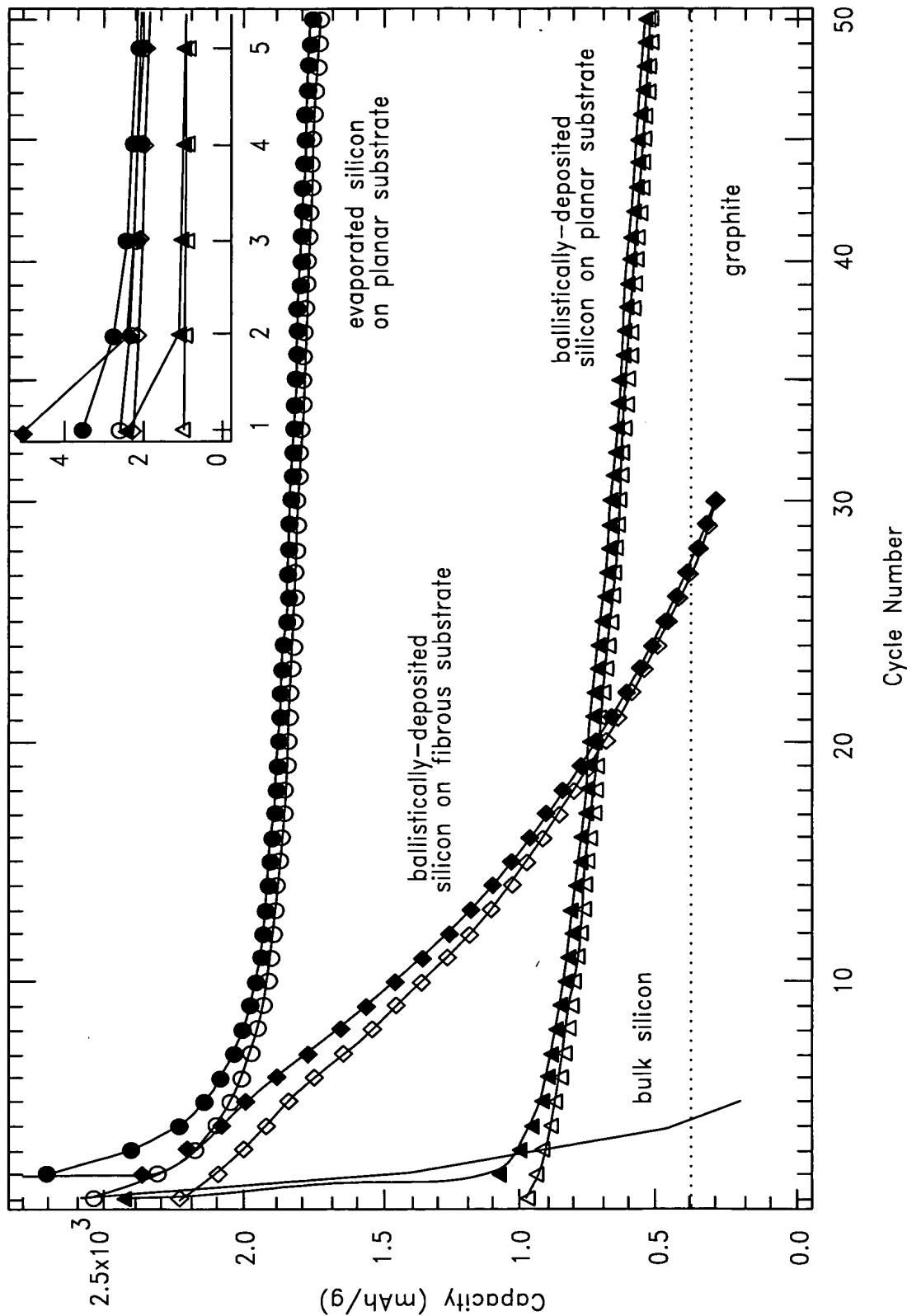


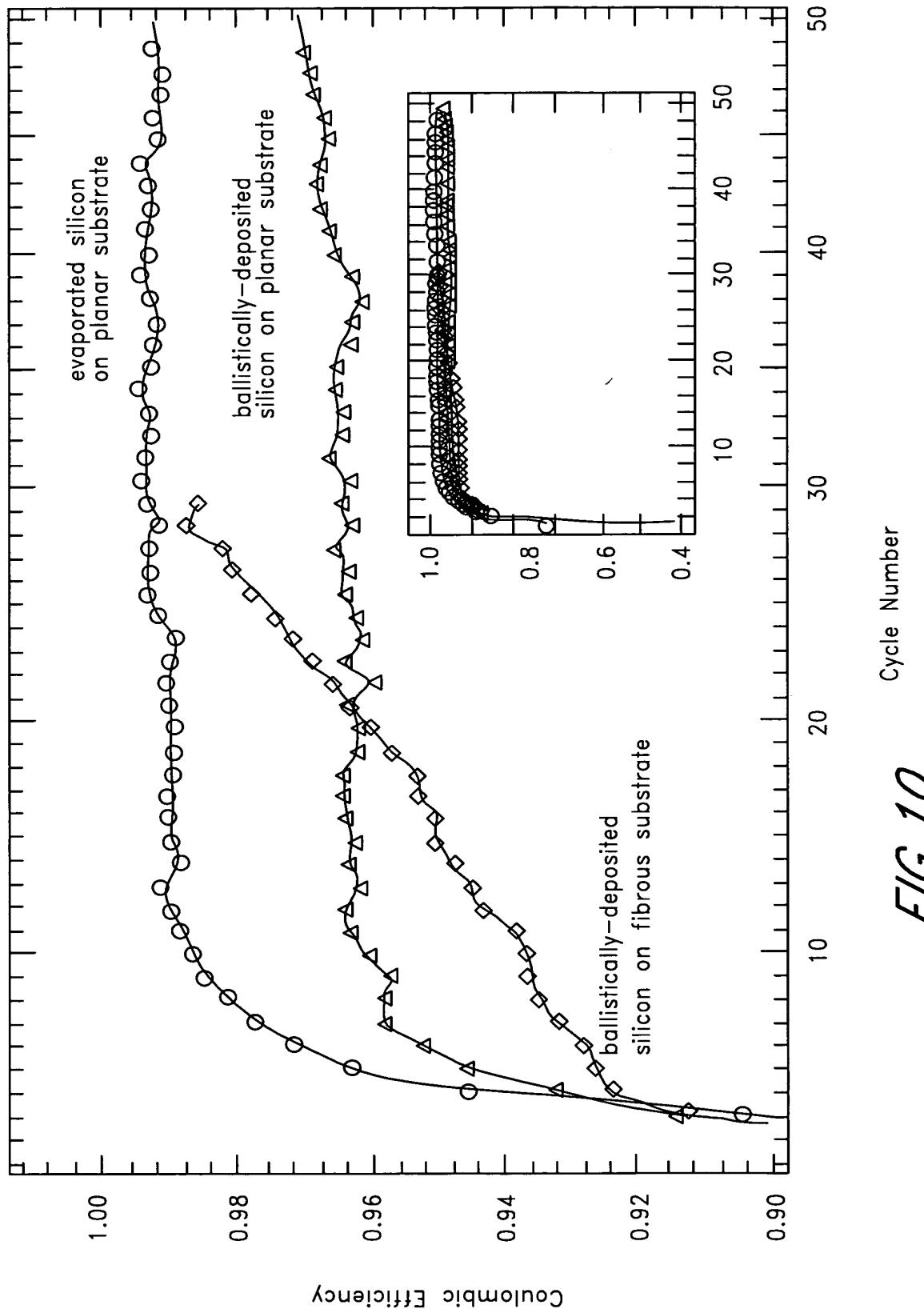
FIG. 7A

FIG. 7B

FIG. 7C

**FIG. 8A****FIG. 8B****FIG. 8C****FIG. 8D****FIG. 8E****FIG. 8F**





12/14

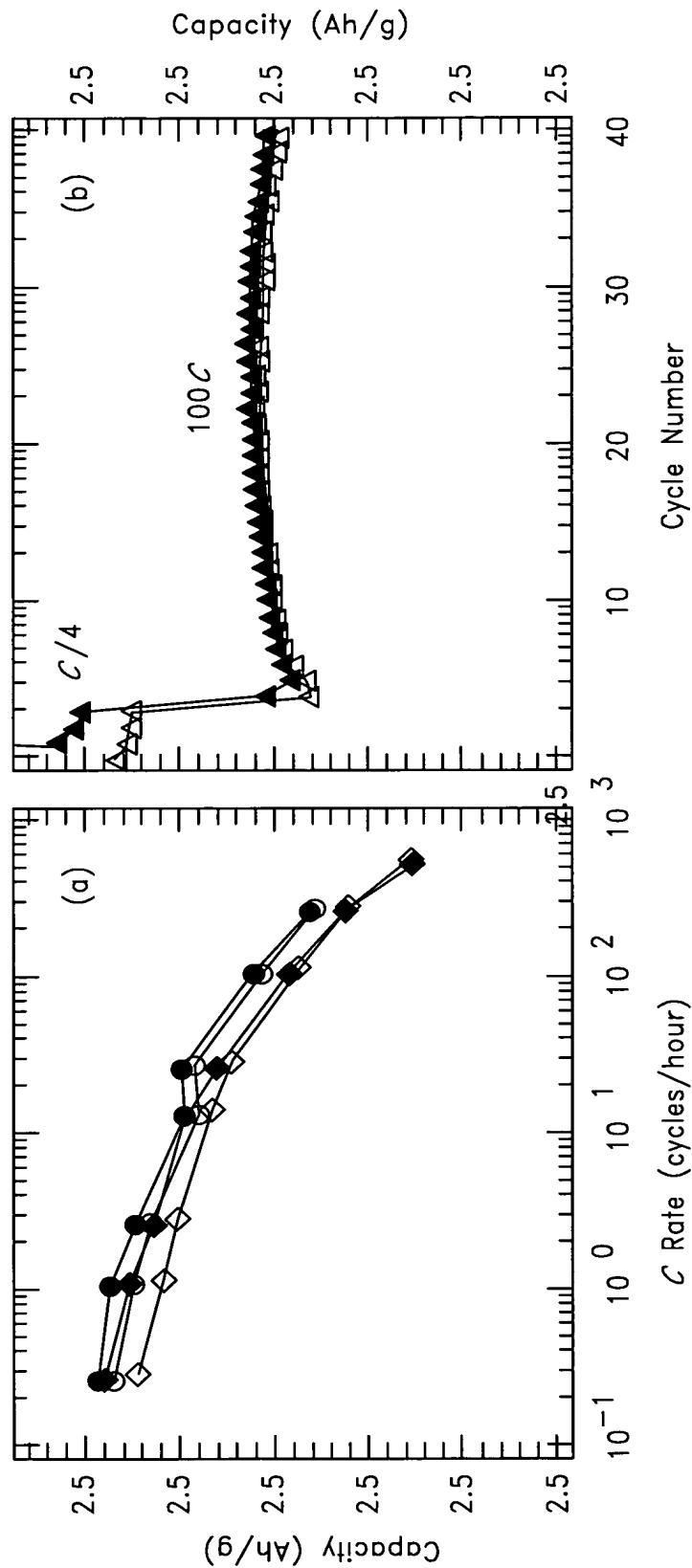


FIG. 11B

FIG. 11A

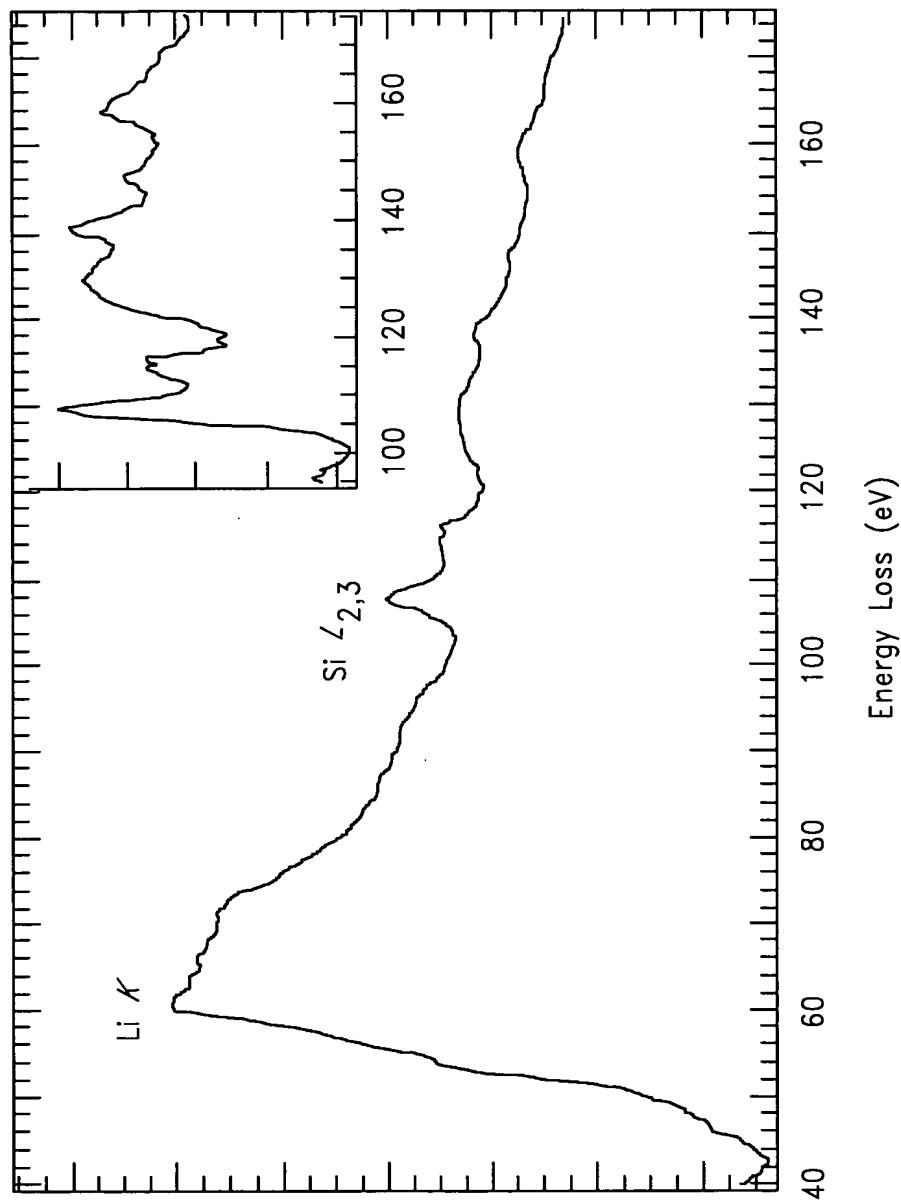


FIG. 12

HIGH-CAPACITY NANOSTRUCTURED SILICON...

Jason Graetz et al.

Appl. No.:10/660,382 Atty. Docket:CTJPL.008A

14/14

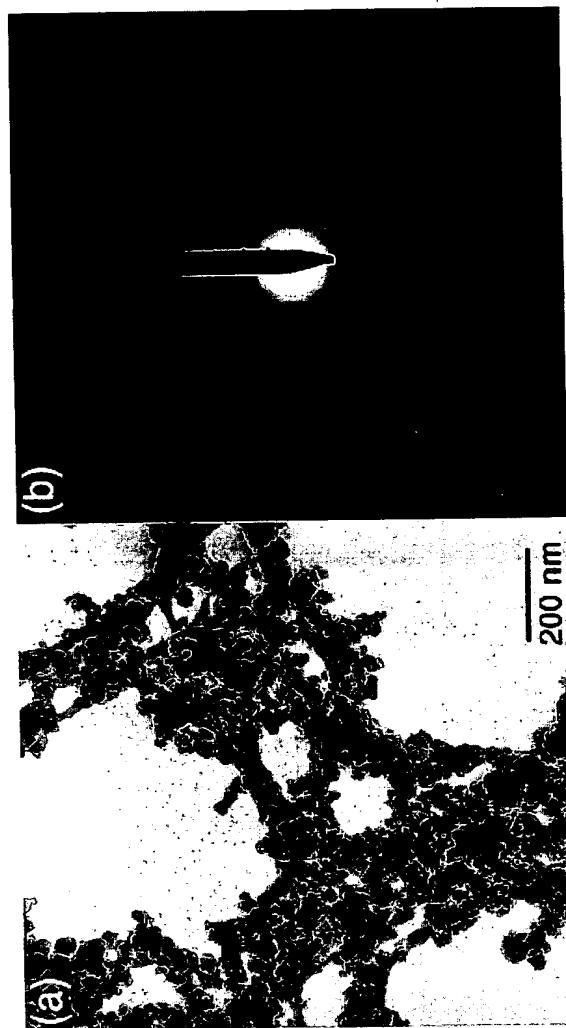


FIG. 13B

FIG. 13A